



# JOURNAL OF EMERGING TECHNOLOGIES AND INNOVATIVE RESEARCH (JETIR)

An International Scholarly Open Access, Peer-reviewed, Refereed Journal

Ref No : JETIR / Vol 7 / Issue 4 / 352

## Confirmation Letter

To,  
SHWETALI KHATU  
Published in : Volume 7 | Issue 4 | 2020-04-24



**Subject:** Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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Registration ID : JETIR 230957

Paper ID : JETIR2004352

Title of Paper : Social Sites Mental Disorders Detection via Online Social Media Mining using Machine Learning Framework

Impact Factor : 7.95 (Calculate by Google Scholar)

DOI :

Published in : Volume 7 | Issue 4 | 2020-04-24

Publication Date: 2020-04-24

Page No : 1142-1145

Published URL : <http://www.jetir.org/view?paper=JETIR2004352>

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Editor In Chief

International Journal of Emerging Technologies and Innovative Research  
(ISSN: 2349-5162)



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